

December 11, 2024 **IGI Report Number** 

Shape and Cutting Style

ADDITIONAL GRADING INFORMATION

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth

Description

Measurements

Carat Weight

Color Grade

Clarity Grade

Polish

Symmetry Fluorescence

Inscription(s)

process.

Type IIa

**GRADING RESULTS** 

GEMOLOGICAL INSTITUTE

# **ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

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Slightly Thick	T 11.5%			$\overline{}$
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	56%			
	1	$\overline{\ }$		
	$\perp$		$\checkmark$	-
		P	ointed	

**CLARITY CHARACTERISTICS** 

PROPORTIONS

LG669417262

PRINCESS CUT

3.09 CARATS

Е

**VS** 1

NONE

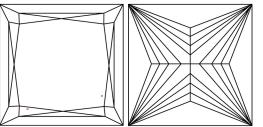
EXCELLENT **EXCELLENT** 

1/31 LG669417262

7.90 X 7.79 X 5.64 MM

LABORATORY GROWN DIAMOND





LG669417262

Report verification at igi.org

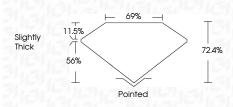
## **KEY TO SYMBOLS**

Red symbols indicate internal characteristics. Green symbols indicate external characteristics. COLOR

D	Е	F	G	Н	Ι	J	Faint	Very Light	Light
CL	ARI1	Y							
IF			W	/S <sup>1-2</sup>			VS <sup>1-2</sup>	SI <sup>1 - 2</sup>	I 1 - 3
Inter Flaw		,		ery Ve ghtly		Ided	Very Slightly Include	Slightly ed Included	Included

LABORATORY GROWN DIAMOND REPORT

December 11, 202	4
IGI Report Numbe	LG669417262
Description	LABORATORY GROWN DIAMOND
Shape and Cutting	g Style PRINCESS CUT
Measurements	7.90 X 7.79 X 5.64 MM
GRADING RESULT	S
Carat Weight	3.09 CARATS
Color Grade	거리는 것이라.
Clarity Grade	VS 1

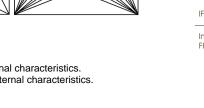


## ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(G1LG669417262
Comments: This Laboratory created by Chemical Vap process. Type IIa	r Grown Diamond was or Deposition (CVD) growth







72.4%

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